

BEST AVAILABLE COPY

U.S. UTILITY Patent Application

PATENT NUMBER and  
ISSUE DATE

APPL NUM 10035257		FILING DATE 01/04/2002		CLASS 438		SUBCLASS 627		GAU 2812		EXAMINER GUERRERO	
**APPLICANTS: Kim Byung-Hee, Lee Jong-Myeong; Lee Myoung-Bum, Choi Gil-Heyun;											
<p>None MG</p> <p>**CONTINUING DATA VERIFIED:</p>											
<p>OR MG</p> <p>**FOREIGN APPLICATIONS VERIFIED: REPUBLIC OF KOREA 2001-932 01/08/2001</p>											
PG-PUB <input type="checkbox"/> DO NOT PUBLISH <input type="checkbox"/>				RESCIND <input type="checkbox"/>				ATTORNEY DOCKET NO			
Foreign priority claimed 35 USC 119 conditions met Verified and acknowledged Examiners's initials MG				yes <input type="checkbox"/> no yes <input type="checkbox"/> no				262/014			
TITLE : Method of fabricating metal lines in a semiconductor device											
U.S. DEPT. OF COM. PAT. & TM. PHO.											

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G.
ISSUE FEE		Primary Examiner	DRAWING	
Amount Due	Date Paid		Sheets Drawg.	Figg.Drawg.
<input type="checkbox"/> TERMINAL DISCLAIMER		Application Examiner	Application Examiner	
			PREPARED FOR ISSUE WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368, Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.	
		<input type="checkbox"/> FD WITH: <input type="checkbox"/> DISK (CRF)	<input type="checkbox"/> CD-ROM (Attached in pocket on right inside flap)	